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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

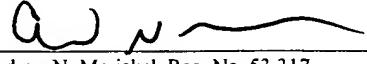
Applicant : Hannu Huotari  
Appl. No. : 10/601,037  
Filed : June 19, 2003  
For : METHOD TO FABRICATE  
DUAL METAL CMOS DEVICES  
Examiner : Christy L. Novacek  
Group Art Unit : 2822

CERTIFICATE OF MAILING

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

May 15, 2006

(Date)

  
Andrew N. Merickel, Reg. No. 53,317

**AMENDMENT AND REQUEST FOR CONTINUED EXAMINATION**

**Mail Stop AF**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

The present paper is submitted with a Request for Continued Examination and is responsive to the Final Office Action mailed on February 13, 2006. As the present amendments are believed to place the application in condition for allowance and do not require extensive consideration, their entry is respectfully requested.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 6 of this paper.